

<p style="text-align: center;">IN THE UNITED STATES PATENT AND TRADEMARK OFFICE</p>	Application Number	10/000,009
	Filing Date	December 04, 2001
	First Named Inventor	SAITO
	Group Art Unit	1763
	Examiner Name	Zervigon, Rudy
	Attorney Docket Number	2922-161
<p>Title: LOW PRESSURE CVD APPARATUS AND METHOD OF MANUFACTURING A THIN FILM</p>		

AMENDMENT AND REQUEST FOR RECONSIDERATION

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

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DEC 15 2003
TC 1700

In response to the outstanding Office Action mailed September 10, 2003, please consider the following remarks.

IN THE CLAIMS:

Amendments to the Claims are reflected in the listing of claims, which begin on page 2 of this paper.